

Notice of References Cited	Application/Control No. 10/748,941		Applicant(s)/Patent Under Reexamination DAVIS ET AL.	
	Examiner Vivian Chen		Art Unit 1773	Page 1 of 3

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2006/0019099	01-2006	Wang et al.	428/412
*	B	US-2003/0175488	09-2003	Asthana et al.	428/212
*	C	US-2006/0017193	01-2006	Asthana et al.	264/173.1
*	D	US-6,306,507	10-2001	Brunelle et al.	428/423.7
*	E	US-6,265,522	07-2001	Brunelle et al.	528/194
*	F	US-4,381,359	04-1983	Idel et al.	524/117
*	G	US-2003/0216539	11-2003	Siclovan et al.	528/272
*	H	US-2003/0207123	11-2003	Brunelle et al.	428/423.7
*	I	US-5,308,894	05-1994	Laughner, Michael K.	523/436
*	J	US-6,900,769	05-2005	Schlieber et al.	343/713
*	K	US-6,583,256	06-2003	Vollenberg et al.	528/196
*	L	US-6,890,979	05-2005	Eichenauer et al.	524/115
*	M	US-6,559,270	05-2003	Siclovan et al.	528/196

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	EP 1 316 419 A2	06-2003	EP	Wang	
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

Notice of References Cited	Application/Control No. 10/748,941		Applicant(s)/Patent Under Reexamination DAVIS ET AL.	
	Examiner Vivian Chen		Art Unit 1773	Page 2 of 3

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,731,213	03-1988	Klepsch, Wilhelm	264/512
*	B	US-4,490,506	12-1984	Sakano et al.	525/67
*	C	US-4,444,950	04-1984	Sakano et al.	525/67
*	D	US-4,438,229	03-1984	Fujimori et al.	524/109
*	E	US-4,895,897	01-1990	Kaufman, Lawrence G.	525/67
*	F	US-4,804,566	02-1989	Paul et al.	428/35.7
*	G	US-5,369,154	11-1994	Laughner, Michael K.	523/436
*	H	US-6,136,441	10-2000	MacGregor et al.	428/412
*	I	US-2001/0016626	08-2001	Vollenberg et al.	525/165
*	J	US-6,589,378	07-2003	Grefenstein et al.	156/222
*	K	US-2003/0162895	08-2003	Gaggar et al.	525/70
*	L	US-6,538,065	03-2003	Suriano et al.	525/182
*	M	US-2004/0142176	07-2004	Wang, Hua	428/412

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

Notice of References Cited	Application/Control No. 10/748,941		Applicant(s)/Patent Under Reexamination DAVIS ET AL.	
	Examiner Vivian Chen		Art Unit 1773	Page 3 of 3

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0158554	07-2005	Wang et al.	428/412
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.